IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRIORITY Application Serial No	10/134,201
Confirmation No	None
PRIORITY Filing Date	April 25, 2002
Inventor	
Assignee	Micron Technology, Inc.
PRIORITY Group Art Unit	
PRIORITY Examiner	J. Kennedy
Attorney's Docket No	MI22-2464
Customer No.	021567
Title: Methods for Forming Capacitor Structures; and Methods	ods for Removal of Organic
Materials	_

INFORMATION DISCLOSURE STATEMENT References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent application of the above-identified application. The above-identified application is a continuation of Application Serial No. 09/835,052, filed on April 13, 2001, now U S Patent No. 6,472,40 B2. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. Copies of the foreign patents and articles are being submitted only for the convenience of the Examiner.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action; therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925

Respectfully submitted,

Dated: 12/12/0.3

Bv:

Reg. No. 46,791

Form PTO-1449			U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO MI22-2464		PRIORITY SERIAL NO. 10/134,201			
·					CANT	APPLICANT Nishant Sinha					
					PRIORITY FILING DATE April 25, 2002			PRIORITY GROUP 2812			
					U.S. PATENT DOCUMENTS		-	-		-	
	1										
*Examiner Initial		Num	ament iber	Date	Name		Class Su		class	Filing Date If Appropriate	
	AA	6,431	1,953	08/02	Carter, et al.		<u> </u>				
	AB	6,416	5,685	07/02	Zhang, et al.						
	AC	6,281	1,535	08/01	Ma, et al.		:				
	AD	3,778	3,530	12/73	Reimann, William George						
	AE	6,468	3.858	10/02	Lou, Chine-Gie						
	AF										
	AG										
	AH										
	Al										
	AJ									·	
	AK								·		
	•			^	FOREIGN PATENT DOCUMENTS	3					** *** *
		Document Number		Date	Country		Class	Subclass	class	Translation	
										Yes No	
	AL					•					
	AM										
	AN	<u> </u>		<u> </u>	<u> </u>						
	AO	<u> </u>									
	AP	-									
	AQ	<u>. </u>									
				OTHER REFE	RENCES (including Author, Title, Date, I	Pertinent Pages, Etc.)					
	AR								,-,-		**
					. <u>.</u>		<u> </u>				
	AS		† "								
				_							
EXAMINER	I—— <u>—</u> I				DATE CONSIDERE	D					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											

EL979978648